

Application/Control No.	Applicant(s)/Patent under Reexamination
10/646,152	3PARK ET AL.
Examiner	Art Unit
Shih-Chao Chen	2821

SEARCHED					
Class	Subclass	Date	Examiner		
343	700MS, 702, 724, 725, 793, 853	3/5/2005	CHEN		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST (See attached printout)	2/3/2005	CHEN		